Notice of Allowability	Application No.	Applicant(s)	
	10/765,854	SAKITA, KOICHI	
	Examiner	Art Unit	
	LUN-YI LAO	2629	
The MAILING DATE of this communication apperature and claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIP of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to and MPEP 1308.	olication. If not includ- will be mailed in due	ed course. THIS
 This communication is responsive to the application filed on 	<u>n January 29, 2004</u> .		
2. 🔀 The allowed claim(s) is/are <u>1-6</u> .			
 3. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). Certified copies not received: 	been received. been received in Application No cuments have been received in this r	national stage applica	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submit	ENT of this application.		
INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
5. 🗌 CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.		
(a) ☐ including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-9	948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the O	ffice action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the			back) of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I 			Note the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal Pa	atent Application (PT0	O-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	 Interview Summary € Paper No./Mail Date 		
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 1/29/2004 Examiner's Comment Regarding Requirement for Deposit of Biological Material 			
	8. Examiner's Statement of Reasons for Allowance		
	9. Other		
	Lun-Yil Primary Em Lun-		
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DETAILED ACTION

1. The prior art made of record and not relied upon is considered pertinent to

applicant's disclosure.

Kobayashi(6,580,227) teaches an plasma display for applying blunt wave in an

initial period.

None of cited references teach a method for driving a three-electrode surface

discharge AC type plasma display comprising generating discharge only in a previous

non-lighted cell that was not lighted in the last sustaining process that was performed

before the initialization so that the wall voltage thereof approaches a wall voltage of a

previous lighted cell that was lighted in the last sustaining process, in the first blunt

wave application among the at least two blunt wave applications; and generating

discharge in the previous lighted cell and the previous non-lighted cell so that the wall

voltage of these cells change to set values, in the second blunt wave application, with

all other limitation cited in claim 1.

2. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Lun-yi, Lao whose telephone number is (571) 272-7671.

August 5, 2006

Ľun-yi Lao

Primary Examiner